



IFW

033082M328

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Shinichi SHINOZUKA, et al.

U.S. Serial No.: 10/581,073

Group Art Unit: To Be Assigned

Filed: : May 31, 2006

Examiner: To Be Assigned

For: METHOD OF CONTROLLING SUBSTRATE PROCESSING
APPARATUS AND SUBSTRATE PROCESSING APPARATUS

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which cites JP Publication No. 2000-223401 cited and discussed on page 4 of Applicants' specification.

It is respectfully requested that the cited document be considered by the Examiner in the above-identified patent application and that the cited document be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

This Information Disclosure Statement is being filed within three (3) months of the filing date of the application. Therefore, it is believed that no fees are due under 37 C.F.R. Section 1.97(b)(3).

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

By: _____

Michael A. Makuch, Reg. No. 32,263
1850 M Street, N.W., Suite 800
Washington, D.C. 20036
Telephone: (202) 263-4300
Fax: (202) 263-4329

August 8, 2006



FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 033082M328	SERIAL NO. 10/581,073
	APPLICANT: Shinichi SHINOZUKA, et al.	
	FILING DATE May 31, 2006	GROUP ART UNIT To Be Assigned

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE, IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
							YES	NO
	AH	2000-223401	8/11/00	Japan			X	
	AI							
	AJ							
	AK							
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	
	AR	
	AS	

EXAMINER:	DATE CONSIDERED:
-----------	------------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.